

Docket No.: 60188-063

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Bunji MIZUNO, et al.

Serial No.:

Group Art Unit:

Filed: April 24, 2001

Examiner:

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

JC971 U.S. PTO  
09/840306  
04/24/01

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Some of the references were cited by or submitted to the U.S. Patent and Trademark Office in parent application Serial No. 09/178,766, filed October 26, 1998, which is relied

Serial No.:

upon for an earlier filing date under 35 USC 120. Thus, copies of these references are not attached. 37 CFR 1.98(d).

Respectfully submitted,

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